

03599.000093

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: J. Lund
NOBUMASA SUZUKI	)	
	:	Group Art Unit: 1763
Application No.: 10/766,816	)	
	:	Confirmation No. 3133
Filed: January 30, 2004	)	
	:	
For: PROCESSING APPARATUS AND	)	
METHOD	:	July 9, 2007

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

FOURTH INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the attached Form PTO-1449. A copy of this document is attached.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the attached Form PTO-1449 be returned indicating that such information has been considered.

A \$180 fee for the Information Disclosure Statement is submitted herewith via Deposit Account 50-3939.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

/Jason M. Okun/  
Jason M. Okun  
Attorney for Applicant  
Registration No. 48,512

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FORM PTO 1449 ( <i>modified</i> )  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO. <b>03599.000093</b>		APPLICATION NO. <b>10/766,816</b>	
				APPLICANT <b>Nobumasa Suzuki</b>			
				FILING DATE <b>January 30, 2004</b>		GROUP <b>1763</b>	

  

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

  

FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT

  

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)		
		<b>Kenneth J. Barlow et al., "The Low-Temperature Anodization of Silicon in a Gaseous Plasma,"</b> <b>36(7) IEEE Transaction on Electron Devices 1279-84 (July 1989).</b>

  

EXAMINER	DATE CONSIDERED
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.